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PATENT  
Customer No. 22,852  
Attorney Docket No. 08137.0004-00000

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Hiroshi SHINRIKI et al. ) Group Art Unit: 1762  
Application No.: 09/657,627 ) Examiner: B. Chen  
Filed: September 8, 2000 )  
For: THIN FILM FORMING METHOD )  
AND THIN FILM FORMING )  
APPARATUS )

Commissioner for Patents  
Washington, DC 20231

Sir:

**AMENDMENT**

Pursuant to a Request for Continued Examination under 37 C.F.R. § 1.114 and  
fee payment filed concurrently herewith, please amend the application as follows:

**IN THE CLAIMS:**

Please amend claim 13, as follows:

*10* 13. (Amended) The method of claim 1, wherein a solution, in which an organic  
metal source of lead, an organic metal source of zirconium, and an organic metal  
source of titanium are dissolved, is transported to a vaporizer, and, by respectively  
vaporizing said organic metal sources by vaporizing said solution, each of said metal  
source gases is generated.

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